

CONSIDERED: /SL/

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Group 1795

Steven A. Soper *et al.*

Examiner Lee, Sin J.

Serial No. 10/734,816

Confirmation No. 3513

Filing Date: December 12, 2003

For: Photoresist-Free Micropatterning on Polymer Surfaces (File Soper 0023.1)

**RESPONSE TO FINAL OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CONSIDERED: /SL/

This paper is submitted in response to the June 13, 2008 final Office Action.